



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2823
Examiner: Fernando L. Toledo

In Re PATENT APPLICATION of:

Applicant(s): Masaru TAKAISHI

Serial No.: 10/766,212

Filing Date: January 29, 2004

For: METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

Atty. Ref.: AI 325

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) **AMENDMENT**
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December 14, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on July 26, 2005, the period for response to which is extended by a Petition for a Two-month Extension of Time filed herewith, please amend the above-identified application as follows:

TITLE AMENDMENTS:

Please delete the current Title and substitute it with the new Title as follows:

--METHOD FOR FILLING A CONTACT HOLE HAVING A SMALL DIAMETER
AND A LARGE ASPECT RATIO--